

Electronic Acknowledgement Receipt

EFS ID:	1293541
Application Number:	10019244
International Application Number:	
Confirmation Number:	1889
Title of Invention:	APPARATUS FOR ATOMIC LAYER CHEMICAL VAPOR DEPOSITION
First Named Inventor/Applicant Name:	Prasad Narhar Gadgil
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Filer:	Stephen Grant Sullivan
Filer Authorized By:	
Attorney Docket Number:	1446NP
Receipt Date:	03-NOV-2006
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Change of Address	FeeAddressForm.pdf	26568	no	1

Warnings:

Information:

Total Files Size (in bytes):	26568
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.